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JO Rec'd PCT/PTO 05 APR 2002

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Comments from Sender: Re: Applicant: MAJIMA et al.; Serial No. 09/890,550

Attached please find a copy of an Official Filing Receipt. Please correct the filing receipt to reflect the following:

The Title of the invention should read "Porous Silicon Carbide Sinter and Silicon Carbide-Metal Composite that are Optimal for a Wafer Grinder Table"

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/890,550	01/14/2002	2812	1436	2000-22	6	27	7

CONFIRMATION NO. 4691

REPLACEMENT FILING RECEIPT



CC000000007721557

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Date Mailed: 03/26/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP00/08284 11/24/2000

Foreign Applications

JAPAN 11-340408 11/30/1999
JAPAN 11-340409 11/30/1999
JAPAN 2000-126085 04/26/2000

Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

Title

Porous silicon carbide sintered compact and silicon carbide metal composite suitable for use in table for wafer polishing machine

Preliminary Class